



JPW

Docket No.: R2180.0193/P193
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Naohiro Ueda

Application No.: 10/801,838

Confirmation No.: 3147

Filed: March 17, 2004

Art Unit: 2811

For: SEMICONDUCTOR APPARATUS AND
METHOD OF MANUFACTURING THE
SAME

Examiner: Not Yet Assigned

REQUEST FOR CORRECTED FILING RECEIPT

U.S. Patent and Trademark Office
220 20th Street S.
Customer Window, Mail Stop Filing Receipt Corrections
Crystal Plaza Two, Lobby, Room 1B03
Arlington, VA 22202

Dear Sir:

Applicant hereby requests that a corrected Filing Receipt be issued in the above-identified patent application. The official Filing Receipt received by Applicant, a copy of which is attached hereto, has an error in the title of the application. The correct title should read as follows:

**SEMICONDUCTOR APPARATUS AND METHOD OF
MANUFACTURING THE SAME**

Application No.: 10/801,838

Docket No.: R2180.0193/P193

Applicant additionally requests that all pertinent U.S. Patent and Trademark Office records relating to the subject application be changed to reflect this correction.

Dated: August 31, 2004

Respectfully submitted,

By 

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UNITED STATES PATENT AND TRADEMARK OFFICE

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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/801,838	03/17/2004	2811	900	R2180.0193/P193	17	16	2

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CONFIRMATION NO. 3147

UPDATED FILING RECEIPT



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Date Mailed: 08/09/2004

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2004
DO/pn
LUS 8.11.04
formalities

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Naohiro Ueda, Hyougo-ken, JAPAN;

Domestic Priority data as claimed by applicant

Foreign Applications

JAPAN 2003-074881 03/19/2003

If Required, Foreign Filing License Granted: 06/02/2004

Projected Publication Date: 11/18/2004

Non-Publication Request: No

Early Publication Request: No

Title

Semiconductor apparatus and method of manufacturing the same
manufacturing

Preliminary Class

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